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S/N 10/590067

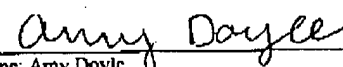
PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	SHIMOMURA et al.	Examiner:	ELEY, Timothy V.
Serial No.:	10/590067	Group Art Unit:	3724
Filed:	August 21, 2006	Docket No.:	08279.1153USWO
Title:	POLISHING PAD AND METHOD FOR MANUFACTURE OF SEMICONDUCTOR DEVICE USING THE SAME		

CERTIFICATE UNDER 37 CFR 1.6(d):

I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on March 24, 2008.

By:



Name: Amy Doyle

AMENDMENT AND RESPONSE

Mail Stop: AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

In response to the Office Action mailed January 23, 2008, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 4 of this paper.